



RCE/2814  
IFW \$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUKASAWA, Shinji**

Group Art Unit: **2814**

Serial No.: **09/855,590**

Examiner: **T. N. QUACH**

Filed: **May 15, 2001**

P.T.O. Confirmation No.: 1417

For. **SEMICONDUCTOR DEVICE HAVING A MULTIPLE LAYER WIRING  
STRUCTURE, WIRING METHOD, WIRING DEVICE, AND RECORDING  
MEDIUM**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: July 8, 2004

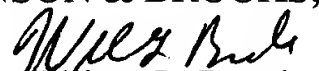
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated February 12, 2004 for two months, from May 12, 2004 to July 12, 2004.

Attached please find a check in the amount of \$1,190.00 to cover the cost of the extension (\$420.00) and to cover the cost of the RCE (\$770.00) for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS,  
HANSON & BROOKS, LLP

  
William L. Brooks

Attorney for Applicant  
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420.00 OP

WLB/mla  
Atty. Docket No. **010623**  
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PATENT TRADEMARK OFFICE